

10/581622

AP3 Rec'd PCT/PTO 05 JUN 2006

IN THE UNITED STATES DESIGNATED/ELECTED OFFICE (DO/EO/US)

In re Application of: )  
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David Thomas FORREST, et al. )  
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International )  
Application No. PCT/US2004/040629 )  
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International )  
Filing Date: 06 December 2004 (06.12.2004)) )  
 )  
U.S. Serial No. )  
 )  
U.S. Filing Date: 05 June 2006 )  
(05.06.2006) )  
 )  
For: FREE-STANDING SILICON CARBIDE )  
ARTICLES FORMED BY CHEMICAL )  
VAPOR DEPOSITION AND METHODS )  
FOR THEIR MANUFACTURE )

Mail Stop PCT  
Commissioner of Patents  
P. O. Box 1450  
Alexandria, Virginia 22313-1450

Attorney Docket No. 52993/326894  
Date: 05 June 2006

**PRELIMINARY AMENDMENT**

Sir:

Kindly amend the above-identified patent application prior to examination.

Amendment to the Specification appear on page 2 of this paper.

A listing of all pending Claims begins on page 3 of this paper.

Remarks appear on page 8 of this paper.